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# Facile H–D exchange in adsorbed methylidyne on Pt{110}–(1×2) and deuteration to gaseous methane

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Hydrogen–deuterium exchange in adsorbed methylidyne,  $\text{CH}_a$ , on Pt{110}–(1×2) has been studied for the first time using supersonic  $\text{D}_2/\text{H}_2$  molecular beams, which provides new insights into the reversible hydrogenation of adsorbed hydrocarbon fragments. The exchange reaction is extremely facile at surface temperatures of 350–450 K and proceeds via a Langmuir–Hinshelwood reaction between  $\text{D}_a$  and a  $\text{CH}_a$  fragment to produce gas phase  $\text{H}_2$  and HD. The  $\text{CD}_a + \text{H}_a$  (i.e., reverse) reaction was also studied and was found to proceed more slowly. Both exchange reactions were successfully modeled and the difference in reaction rates is explained using zero point energy differences alone. Finally, we demonstrate that with high incident  $\text{D}_2$  fluxes  $\text{CH}_a$  can be completely deuterated to produce gaseous  $\text{CHD}_3$  and  $\text{CD}_4$ . © 2001 American Institute of Physics.  
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## I. INTRODUCTION

Interest in the reactivity of  $\text{C}_1$  hydrocarbon fragments on metal surfaces arises from their presence as reactive intermediates in technologically important processes such as Fischer Tropsch synthesis<sup>1,2</sup> and the oxidative coupling of methane. Most studies to date have concentrated on  $\text{CH}_{3a}$ , due to the simplicity in preparing pure adlayers, by either thermal decomposition of methyl halide precursors<sup>3–7</sup> or using a  $\text{CH}_3$  radical source.<sup>8,9</sup>

The rehydrogenation and exchange of  $\text{CH}_{3a}$  has been studied by many groups.<sup>3–5,8</sup> Using  $\text{CH}_3\text{I}$  as a precursor, Zaera *et al.*<sup>3–5</sup> found that rehydrogenation to methane occurs with high selectivity if either  $\text{D}_2$  or  $\text{H}_2$  is coadsorbed, and dehydrogenation to  $\text{C}_a$  is only a minor pathway. When  $\text{D}_2$  is co-adsorbed, the major product is  $\text{CH}_3\text{D}$  which is formed by the elementary reaction,  $\text{CH}_{3a} + \text{D}_a \rightarrow \text{CH}_3\text{D}$ . However, measurable amounts of methane products produced by multiple H–D exchange reactions were observed and are attributed to a rapid  $\text{CH}_{2a}/\text{CH}_a$  interconversion. Using a methyl radical source to produce  $\text{CH}_{3a}$  adlayers on Pt{111}, Fairbrother *et al.*<sup>8</sup> found that  $\text{CH}_{3a}$  is rehydrogenated exclusively to  $\text{CH}_3\text{D}$ . This competes with dehydrogenation which is favored at low  $\text{CH}_{3a}$  and  $\text{D}_a$  precoverages. They found no evidence for H–D exchange in  $\text{CH}_{3a}$  during rehydrogenation. The discrepancies between the findings of the two groups may be due either to perturbation of the process in the presence of coadsorbed  $\text{I}^-$  or to the presence of a small amount of  $\text{CH}_{2a}$  not observed by Fairbrother *et al.*<sup>8</sup>

To date,  $\text{CH}_a$  exchange and rehydrogenation has not been studied experimentally. This is primarily due to the fact that until recently<sup>10</sup> there was no way of preparing a sufficiently pure  $\text{CH}_a$  adlayer. From DFT slab calculations performed by Michaelides and Hu on Pt{111}<sup>11</sup> and by Nørskov and co-workers on Ni{111},<sup>12</sup> activation energies for  $\text{CH}_a$  hydrogenation to  $\text{CH}_{2a}$  of 94  $\text{kJ mol}^{-1}$  and 70  $\text{kJ mol}^{-1}$  were reported, respectively. Here we provide an experimental basis for benchmarking calculations of this kind.

The importance of quantum mechanical (QM) tunneling in H transfer reactions is still a matter for debate. Several investigators have used tunneling to explain the dependence of alkane sticking probabilities over transition metals on incident kinetic energy.<sup>13,14</sup> In fact, Harris and Luntz<sup>15</sup> have provided a theoretical treatment for methane dissociative adsorption where H tunneling is the rate determining step for C–H bond activation. The above studies are by no means conclusive and the studies which have provided the most insight into this question have involved determining the magnitude of the kinetic isotope effect (KIE): In a normal kinetic isotope effect, the reaction rates of C–H dissociation,  $k_H$ , and C–D dissociation,  $k_D$ , are determined solely by the different depths of the zero point energy in the potential energy well, and hence by the consequently different activation energies for dissociation (note the expected value for  $k_H/k_D$  will also depend on the surface temperature). By contrast, if tunneling of H or D through the activation barrier to dissociation is significant, the different probabilities of tunneling for H or D due to their different masses, will also affect  $k_H/k_D$ .

Yata and Madix<sup>16</sup> found that  $k_H/k_D=3.1$  for simple C–H bond cleavage in ethylene on Pt{111} and Watson *et al.*<sup>17</sup> found a normal kinetic isotope effect for methylidyne C–H bond cleavage on Pt{110}–(1×2); these results can be explained using zero point energy differences alone. Fairbrother *et al.*<sup>8</sup> found that  $\text{CD}_{3a}$  dedeuteration occurs about 5–7 K above  $\text{CH}_{3a}$  dehydrogenation indicating  $k_H/k_D>1$ , again a normal isotope effect. Methyl rehydrogenation experiments performed by Harrison and Ukraintsev<sup>18</sup> showed a small isotope effect ( $k_H/k_D=1.3$ ) measured at 240 K, which also suggest that tunneling across the activation barrier is insignificant for both methane dissociation and formation. In this paper we study the  $\text{CD}_a + \text{H}_a$  and  $\text{CH}_a + \text{D}_a$  exchange reactions using molecular beam reaction spectroscopy and determine the importance of QM tunneling for both these reactions.

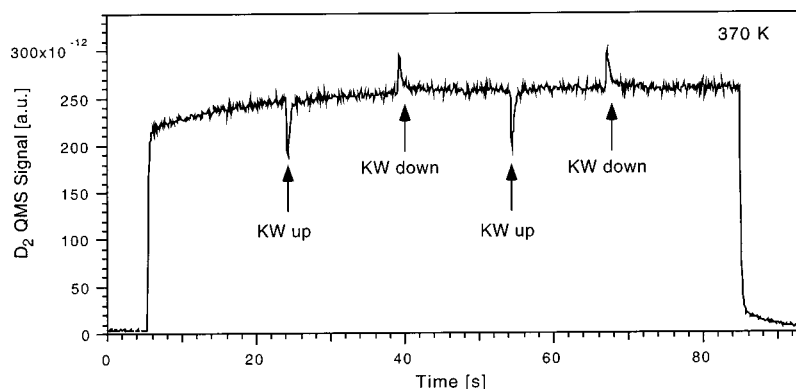


FIG. 1. KW experiment to measure the net sticking probability of  $D_2$  at a surface temperature of 370 K and beam flux of  $0.024 \text{ ML s}^{-1}$ .

## II. EXPERIMENTAL DETAILS

The experimental apparatus is described in detail elsewhere.<sup>19</sup> The sample is mounted centrally on a manipulator in an ultrahigh vacuum chamber with a base pressure of  $<2 \times 10^{-10}$  mbar. The molecular beam is sourced by supersonic expansion through a  $50 \mu\text{m}$  nozzle, skimmed, differentially pumped and collimated before entering the sample chamber. An inert King and Wells (KW) flag just in front of the crystal is used to control the dosing time and to measure sticking probabilities.<sup>20</sup> A source stage flag can also be inserted to prevent impingement on the KW flag. The surface temperature ( $T_s$ ) is monitored by a crystal-mounted thermocouple referenced to an electronic ice-point and is regulated by programmed resistive heating. The partial pressures of up to 16 individual gases can be monitored using a fixed quadrupole mass spectrometer (QMS) situated behind the crystal.

The Pt sample, 11 mm diameter by 1 mm thick, was cut to within  $0.1^\circ$  of the {110} plane. Initial cleaning of the crystal was achieved by repeated cycles of ion sputtering, annealing, and oxygen treatment. Routine cleaning consisted of annealing at 1240 K followed by exposure to oxygen for 5 minutes while cooling from 1100 to 950 K and then annealing for 15 minutes at 950 K. This procedure yields a clean Pt{110}-(1×2) surface which gives a sharp LEED pattern and oxygen thermal desorption spectra that are in good agreement with the literature.<sup>21</sup> The  $\text{CH}_4$  and  $\text{O}_2$  used were

$>99.9995\%$  and  $99.995\%$  pure, respectively, as quoted by the suppliers [Messer (UK) Ltd.]. The supersonic methane beams used in these experiments had a composition of 8%  $\text{CH}_4$ –92% He and the nozzle was heated to 790 K, giving the methane molecular beam a translational energy of 580 meV, estimated on the basis of an ideal supersonic expansion.

The  $\text{H}_2$  and  $\text{D}_2$  beams employed were produced using a room temperature nozzle. The flux, which was calibrated using a spinning rotor gauge (SRG), was determined using the QMS pressure rise in the main chamber while beaming and could be varied by adjusting the pressure behind the nozzle. All coverages are quoted in monolayers (ML) ( $1 \text{ ML} \equiv 9.22 \times 10^{14} \text{ molecules cm}^{-2}$ ). The coverages were determined using the King and Wells technique<sup>20</sup> and by comparison of temperature programmed desorption (TPD) areas with earlier studies.<sup>22,23</sup>

## III. RESULTS AND DISCUSSION

### A. The reactive $D_2$ sticking probability on a clean Pt{110}-(1×2) crystal

Before the exchange process was studied, the adsorption/desorption kinetics of  $\text{H}_2$  and  $\text{D}_2$  on the clean Pt{110}-(1×2) surface were examined. At surface temperatures below the  $\text{H}_2$  desorption temperature of 310 K,<sup>24</sup> the initial disso-

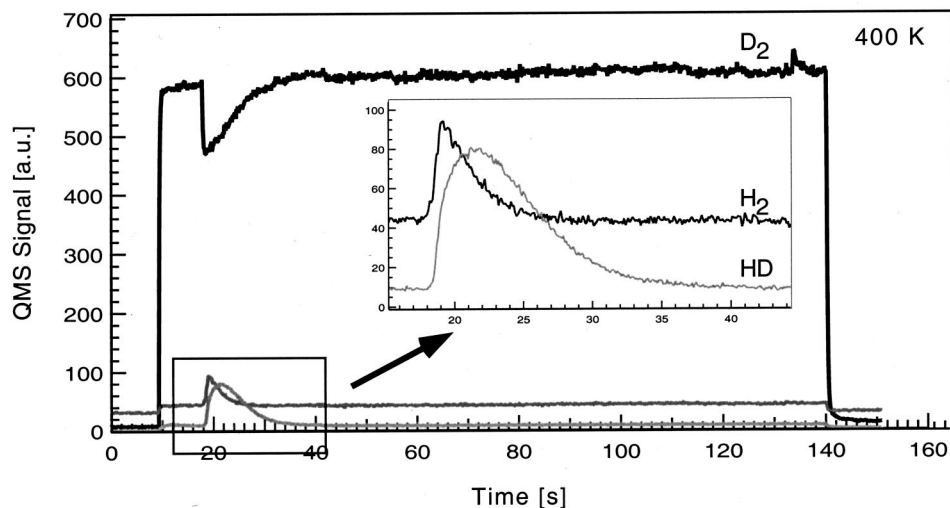


FIG. 2. The  $D_2$  exchange of H in  $\text{CH}_a$  to produce  $\text{H}_2$  and HD. The  $D_2$  beam flux is  $0.062 \text{ ML s}^{-1}$ , the  $\text{CH}_a$  coverage is 0.045 ML and the surface temperature is 400 K.

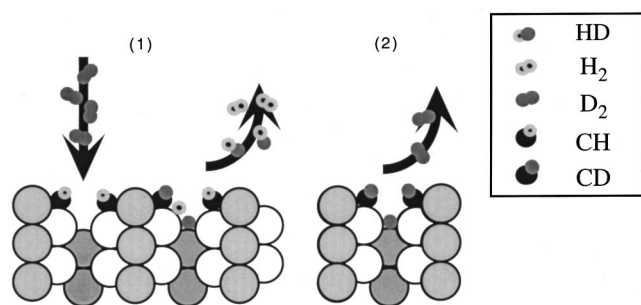


FIG. 3. Schematic of  $D_2$  exchange of H in  $CH_a$ ; (1) the  $D_2$  beam impinges, dissociates and exchanges, producing HD and  $H_2$ ; (2)  $D_2$  beam turned off.

ciative sticking probability on the clean surface is 0.3 for each isotope.<sup>25</sup> At surface temperatures close to and above the desorption temperature, where desorption becomes significant, the KW technique<sup>20</sup> measures a net sticking probability.<sup>26</sup> Figure 1 shows a typical KW sticking experiment for a  $D_2$  beam at a surface temperature of 370 K. After  $\sim 5$  s the source stage flag is opened and the  $D_2$  beam impinges directly against the inert KW flag. The randomly scattered  $D_2$  molecules cause a rise in the  $D_2$  pressure, which is measured using the fixed QMS. After 24 s the KW flag is raised and the beam impinges directly against the crystal. The scattered intensity is reduced because a fraction of the  $D_2$  molecules sticks. This drop in pressure is used to determine an initial net sticking probability of 0.23. After 40 s the KW flag is lowered to block the beam from impinging directly against the crystal. There is a small  $D_2$  pulse which has the same area and hence the same number of molecules as the drop in pressure when the flag was raised. The flag was raised and lowered again after 55 and 66 s, respectively, with identical responses. This shows that the processes taking place at the surface are completely reversible. The observed response can be explained if we consider the following equilibrium which exists above the desorption temperature:



where  $s$ ,  $F_{D_2}$ , and  $k_d$  are the absolute sticking probability,  $D_2$  flux at the crystal and the rate constant for desorption, respectively. When the  $D_2$  beam impinges directly against the

crystal the  $D_2$  pressure (flux) at the crystal increases. According to le Chatelier's principle this causes the equilibrium to shift to the right: some  $D_2$  molecules dissociatively adsorb, increasing the surface concentration of atomic  $D_a$ . When the KW flag is lowered, the  $D_2$  beam is blocked and thus the  $D_2$  pressure at the crystal is reduced. The equilibrium shifts to the left and a pulse of  $D_2$  is observed. The identical response on opening and closing the KW flag again shows that the process is completely reversible. This method was used to determine the net sticking probability at a surface temperature of 400 K and it was found to be 0.13.

## B. Hydrogen–deuterium exchange in adsorbed methylidyne

In our earlier work<sup>10</sup> we demonstrated that a pure methylidyne (CH) adlayer could be formed on Pt{110} by adsorbing methane from a supersonic molecular beam source at a crystal temperature of 370 K. Saturation exposure yields an ordered  $c(2 \times 4)$  overlayer at a coverage of 0.25 ML. If the crystal temperature during  $CH_4$  exposure is lowered to 300 K, the adlayer consists of CH and H adatoms, but heating to 370 K results in recombinative desorption of the H adatoms as  $H_2$ . At temperatures above 400 K the CH adlayer begins to decompose, producing gaseous  $H_2$  and residual carbon. It was concluded that adsorbed CH is the only stable surface dissociation product over the surface temperature range from 350 to 400 K;<sup>10</sup> at these temperatures the remaining H adatom coverage is negligible.

The H in  $CH_a$  can be exchanged using a  $D_2$  beam at a surface temperature of 400 K. The  $CH_a$  adlayer is prepared by dosing the  $0.42 \text{ ML s}^{-1}$  He/ $CH_4$  beam described in the experimental section for 25 s, at a surface temperature of 370 K. A  $D_2$  beam with a flux of  $0.062 \text{ ML s}^{-1}$  is employed to initiate the exchange reaction. In the results shown in Fig. 2, at 10 s the source stage flag is raised and the  $D_2$  is randomly scattered from the inert KW flag, resulting in a rise in  $D_2$  pressure. The KW flag is raised after 18 s which leads to an instantaneous decrease in the  $D_2$  pressure. The  $D_2$  initial reactive sticking probability is increased from 0.13 on the clean surface, as described in Sec. III A, to 0.21. The time required for the net sticking probability to return to zero ( $\sim 17$  s) is much greater than for the clean surface (less than

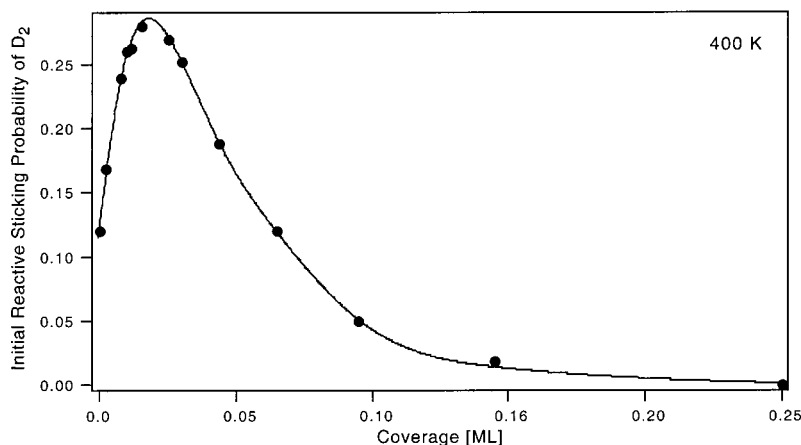


FIG. 4. Initial reactive  $D_2$  sticking probability as a function of  $CH_a$  coverage, at a  $D_2$  beam flux of  $0.062 \text{ ML s}^{-1}$  and a surface temperature of 400 K.

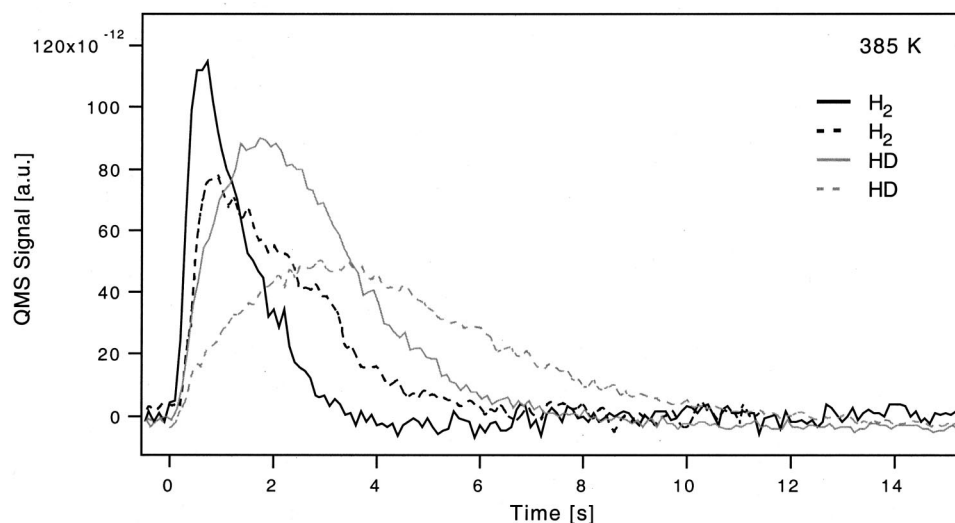


FIG. 5.  $D_2$  exchange of H in  $CH_a$ , to produce  $H_2$  and HD, with  $D_2$  fluxes of  $0.08 \text{ ML s}^{-1}$  (solid lines) and  $0.04 \text{ ML s}^{-1}$  (dashed lines). The  $CH_a$  coverage and surface temperature were  $0.05 \text{ ML}$  and  $370 \text{ K}$ , respectively.

2 s, Fig. 1). The  $H_2$  and HD partial pressures increase while exchange is taking place. These two product profiles have completely different peak shapes, as shown magnified in the inset to Fig. 2. The  $H_2$  signal rises to a maximum almost instantaneously ( $\sim 1 \text{ s}$ ), while the HD signal rises more slowly to a maximum after 4 s and slowly decays to the base value. There is also a small pulse of  $D_2$  when the KW flag is lowered after  $\sim 135 \text{ s}$ ; as for the clean surface, it is due to recombination and desorption of atomic  $D_a$  when the  $D_2$  beam is removed.

The processes taking place on the surface during exchange are shown schematically in Fig. 3. The  $D_2$  adsorbs dissociatively and exchanges with  $CH_a$  to produce atomic  $H_a$ , which can recombine with either  $H_a$  or  $D_a$  atoms to produce  $H_2$  or HD, respectively. The implicit assumption that exchange is preceded by  $D_2$  dissociation is justified below.

After exchange was complete, the crystal temperature was uniformly ramped at a rate of  $6 \text{ K s}^{-1}$  and the  $H_2$ ,  $D_2$ , and HD partial pressures followed. These products arise from decomposition of CH and CD on the surface. After exchange with a high flux  $D_2$  beam the only product is  $D_2$ , with a peak maximum at  $480 \text{ K}$ . However, if the crystal temperature is not ramped immediately, a small HD signal is obtained. This is due to exchange of  $CD_a$  with background  $H_2$ .

The deuterium exchange reaction was repeated with different initial precoverages of  $CH_a$ , at the surface temperature of  $400 \text{ K}$ . Figure 4 shows the variation of the  $D_2$  initial reactive sticking probability with  $CH_a$  precoverage. The reactive  $D_2$  dissociative sticking probability increases from 0.13 at close to zero CH coverage to a maximum of 0.28 at a CH coverage of  $0.02 \text{ ML}$ , then decreases to zero at  $CH_a$  saturation coverage. Here we note that  $D_2$  must dissociate for exchange to take place. If the mechanism was Eley-Rideal, involving a reaction between incident  $D_2$  and adsorbed  $CH_a$ , the sticking probability would increase continuously with  $CH_a$  coverage. Second, a reactive sticking probability of 0.28 at a CH coverage of  $0.02 \text{ ML}$ , which is nearly the same as that for the absolute sticking probability on the clean surface below the desorption temperature, i.e., at  $300 \text{ K}$ , shows that the reaction is extremely efficient. In fact, if we assume that at a  $CH_a$  coverage of  $0.02 \text{ ML}$  every  $D_2$  that dissociates exchanges before it desorbs and that each  $CH_a$  blocks one site for  $D_2$  adsorption, the reactive sticking probability is given by  $s_0(1 - 0.02/0.25)^2 = 0.27$ , which agrees within experimental error with the observed value of 0.28. At coverages below  $0.02 \text{ ML}$  there are not enough  $CH_a$  fragments to react with every  $D_2$  that dissociates and  $D_2$  recombinative desorption become more significant. Using this simple model we would expect the reactive sticking probability to drop as

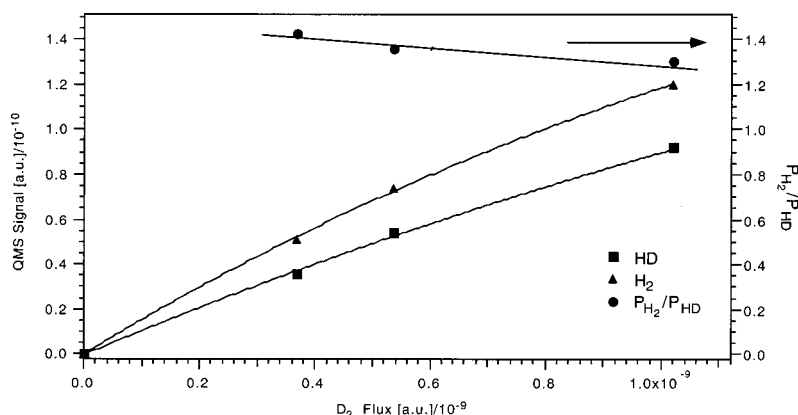


FIG. 6. The maximum rate of  $H_2$  and HD production as a function of  $D_2$  flux at a surface temperature of  $385 \text{ K}$  (left-hand axis). The corresponding ratio of maximum  $H_2$  and HD production rates is also included (right-hand axis).



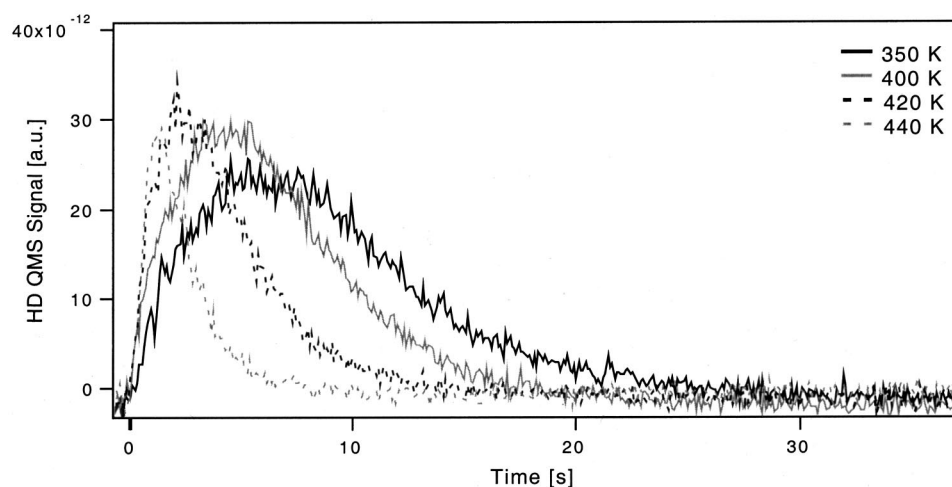


FIG. 7. HD produced by  $D_2$  exchange of H in  $CH_a$  over the surface temperature range 350–440 K. The  $D_2$  beam flux is  $0.022 \text{ ML s}^{-1}$  and  $CH_a$  precoverage is 0.05 ML. The  $CH_a$  precoverage decreases as the reaction temperature increases above 400 K as a result of the conversion of  $CH_a$  to  $C_a$ .

$(1 - \theta_{CH})^2$  at coverages above 0.02 ML; as there is sufficient  $CH_a$  to react with all the dissociated  $D_2$ ,  $CH_a$  simply acts as a site blocker to  $D_2$  dissociation. However, the sticking probability drops off more quickly than expected, indicating that the energetics for the  $CH_a + D_a$  exchange reaction and  $D_2$  dissociative adsorption are coverage dependent.

### C. Influence of $D_2$ flux and surface temperature on the $CH_a + D_a$ exchange reaction

We next examined the influence of  $D_2$  flux on the  $CH_a + D_a$  exchange reaction. The product profiles for the reaction of a 0.05 ML  $CH_a$  overlayer and a  $D_2$  beam with fluxes of  $0.08 \text{ ML s}^{-1}$  and  $0.04 \text{ ML s}^{-1}$  can be seen in Fig. 5. The reaction rate increases when the  $D_2$  flux, and hence the  $D_a$  coverage, are increased, while the peak shapes remain unchanged. The QMS signal at the  $H_2$  and HD peak maxima are plotted versus the  $D_2$  beam flux in Fig. 6. Again we see that increasing the  $D_2$  beam flux increases the peak heights (rate) of both  $H_2$  and HD. The ratio of the peak heights is also included and we find that the rate of HD production relative to  $H_2$  is higher when the  $D_2$  flux is increased. Clearly an increased  $D_a$  coverage increases the rate of HD production.

The effect of surface temperature on the product profiles over the temperature range 350–440 K are shown in Figs. 7 and 8. The  $CH_a$  adlayer had a coverage of 0.05 ML and the  $D_2$  flux was  $0.022 \text{ ML s}^{-1}$ . Increasing the surface temperature from 350 to 400 K had very little effect on the temporal profiles of the  $H_2$  and HD produced. The rate of the reaction increases slightly, with the HD peak maximum occurring after  $\sim 7$  s at 350 K and  $\sim 5$  s at 400 K while the  $H_2$  peak remains unchanged. Increasing the surface temperature to 420 K produces a more noticeable change. There is some conversion of  $CH_a$  to  $C_a$  on heating to this temperature<sup>10</sup> before the exchange experiment is performed, as seen by the decrease in the  $H_2$  and HD peak areas. The peak maxima for both  $H_2$  and HD production occur after shorter amounts of time than at 400 K. At 440 K there is further conversion of  $CH_a$  to  $C_a$  and the exchange reaction is completed after about 7 s. To completely understand what is happening, we need to look at the corresponding  $D_2$  reactive sticking probability curves, Fig. 8(b). In the temperature range 350–400 K the initial reactive sticking probability stays almost constant, at 0.18. As the temperature increases, the reactive sticking probability increases to 0.30 at 440 K. The reason for this is the increasing conversion of  $CH_a$  to  $C_a$ . At 440 K

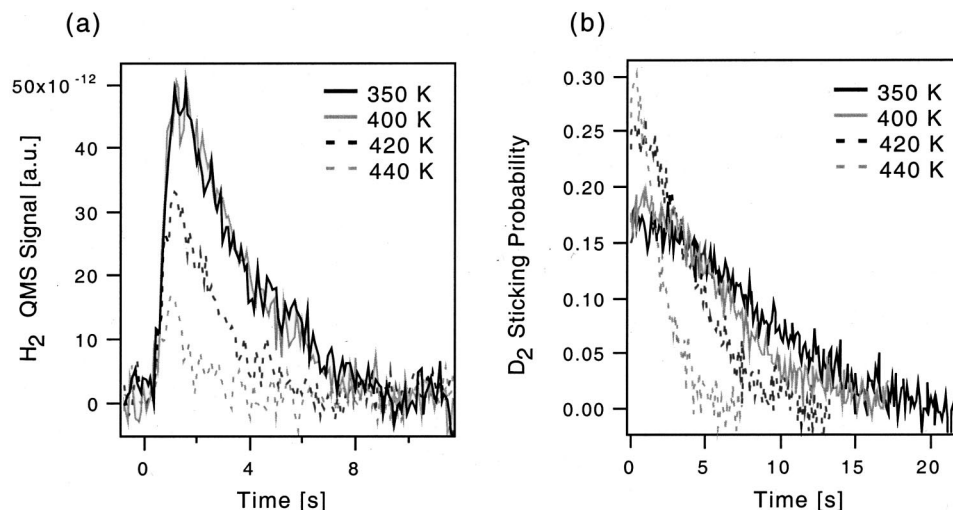


FIG. 8. (a)  $H_2$  produced by  $D_2$  exchange of H in  $CH_a$  over the surface temperature range 350–440 K. The  $D_2$  beam flux is  $0.022 \text{ ML s}^{-1}$  and the  $CH_a$  precoverage is 0.05 ML. (b) Reactive  $D_2$  sticking for the same reaction.

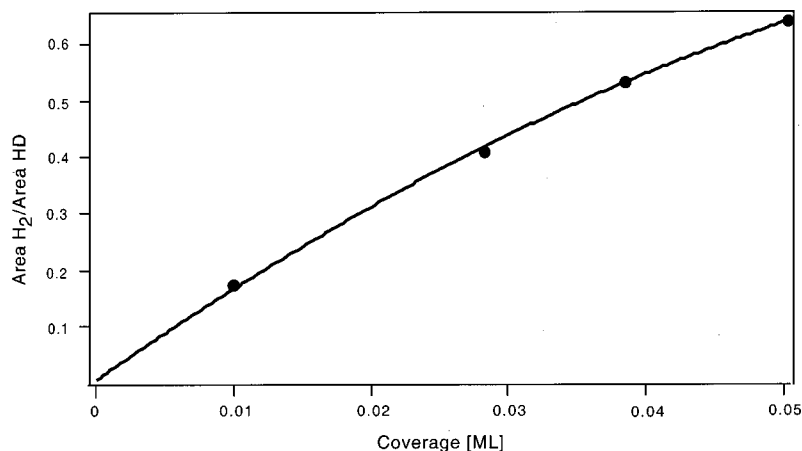


FIG. 9. Ratio of the amount of H<sub>2</sub> to HD produced by the D<sub>2</sub> exchange of H in CH<sub>a</sub> as a function of CH<sub>a</sub> coverage. The D<sub>2</sub> beam flux is 0.022 ML s<sup>-1</sup>.

the CH<sub>a</sub> coverage decreases to 0.014 ML, which is near the maximum in the D<sub>2</sub> reactive sticking versus CH<sub>a</sub> coverage curve, Fig. 4. Therefore, the large increase in rate between 400 and 440 K can be simply attributed to the increased D<sub>2</sub> sticking probability and hence the D<sub>a</sub> coverage. This shows that the surface reaction is not very sensitive to surface temperature in this regime and must have quite a low activation energy.

Figure 9 shows the ratio of the areas of the H<sub>2</sub> produced divided by that of the HD produced versus the the CH<sub>a</sub> coverage (corrected for conversion of CH<sub>a</sub> to C<sub>a</sub>). We find that the relative amount of HD produced increases with decreasing CH<sub>a</sub> coverage and extrapolates to 100% HD as the CH<sub>a</sub> coverage approaches zero. No quantitative conclusion can be reached from the shape of the curves, as the experiments were not performed at constant temperature. However, the results are consistent with our model: as the CH<sub>a</sub> coverage decreases the amount of H<sub>a</sub> produced decreases and an exchanged H<sub>a</sub> atom has a greater chance of combining with a D<sub>a</sub> atom, increasing the relative amount of HD.

#### D. H<sub>2</sub> exchange of D<sub>a</sub> in CD<sub>a</sub>: Relative rate and selectivity

The exchange reaction is completely reversible and can be driven in the opposite direction by beaming H<sub>2</sub> at a CD<sub>a</sub> adlayer. However, the rate of the reaction is slower in this direction and the selectivity is completely different, with only a relatively small amount of D<sub>2</sub> being produced. Figure 10 shows a comparison of the exchange reaction in each direction using identical fluxes of D<sub>2</sub> and H<sub>2</sub>. For the CD<sub>a</sub> + H<sub>a</sub> exchange reaction the rate of the product formation reaches a maximum in less time than for the CH<sub>a</sub> + D<sub>a</sub> reaction. However, the reaction takes almost twice as long to go to completion. The difference in reaction rates must be attributed either to zero point energy differences or to quantum mechanical tunneling of the H atom through the reaction barrier. We discuss this further below.

The reaction rate and selectivity for the CD<sub>a</sub> + H<sub>a</sub> reaction were also investigated as a function of H<sub>2</sub> flux. Figure 11 shows the maximum rate of D<sub>2</sub> and HD production as function of H<sub>2</sub> flux. Again we find that the rate increases with

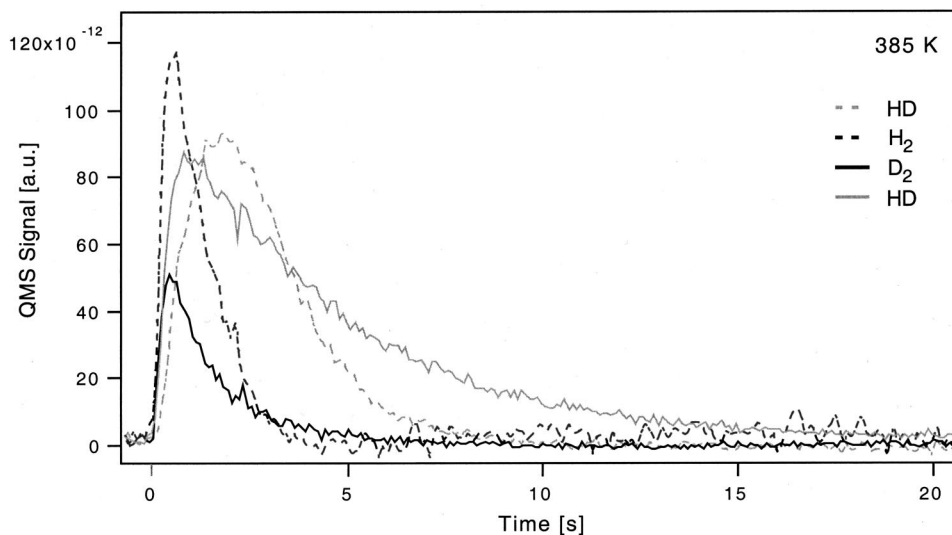


FIG. 10. Product profiles for the CH<sub>a</sub> + D<sub>a</sub> (dashed lines) and CD<sub>a</sub> + H<sub>a</sub> (solid lines) reactions at a surface temperature of 385 K. The H<sub>2</sub>/D<sub>2</sub> flux is 0.08 ML s<sup>-1</sup> and the CH<sub>a</sub>/CD<sub>a</sub> coverage is 0.05 ML.

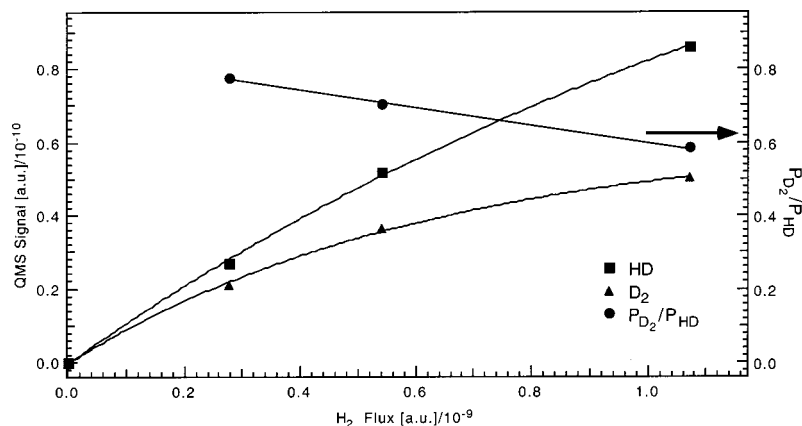
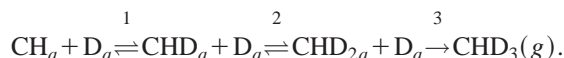


FIG. 11. Maximum rate of  $D_2$  and HD production as a function of  $H_2$  flux at a surface temperature of 385 K (left-hand axis). The ratio of the  $D_2$  to HD maximum rates is also included (right-hand axis).

increasing flux. However, the rate of  $D_2$  production seems to be approaching an asymptote value. The relative selectivity to  $D_2$ , determined by the ratio of the maximum rates is also included. We find that the fraction of  $D_2$  produced decreases with increasing  $H_2$  flux. This is also consistent with our model: the selectivity to  $D_2$  decreases as the  $H_a$  coverage increases.

### E. Rehydrogenation of $CH_a$ to form gas phase $CHD_3$ and $CD_4$

Using a high flux  $D_2$  beam ( $\sim 1.2 \text{ ML s}^{-1}$ ) we found that  $CH_a$  can be completely deuterated to produce gas phase  $CHD_3$  and  $CD_4$ . Figure 12 shows the rehydrogenation of a  $0.12 \text{ ML } CH_a$  adlayer at a surface temperature of 370 K. There is a small sharp  $CHD_3$  peak and a  $CD_4$  peak which rises sharply to a maximum and decreases slowly until the reaction is complete after about 500 s. The inset is the magnification of the first few seconds of the reaction. The  $CHD_3$  maximum occurs after  $\sim 1 \text{ s}$  while the  $CD_4$  maximum occurs after  $\sim 7 \text{ s}$ , by which time the rate of  $CHD_3$  production is negligible. The exchange reaction to produce HD and  $H_2$  (not shown here) is complete before the  $CD_4$  signal reaches its maximum. These findings are consistent with a stepwise deuteration mechanism: i.e.,



Each of the surface steps is reversible, with  $CD_a + H_a$  being an alternative product of step (1), i.e., the exchange reaction.  $CHD_3$  is formed only if deuteration occurs without exchange taking place at any step. Therefore, the maximum in  $CHD_3$  production occurs almost instantaneously (the first data point after the KW flag is raised), before exchange to  $CD_a$  is complete. We note that no  $C_2$  species were observed in the gas phase.

To determine whether the  $CH_a$  adlayer was completely removed by deuteration, a titration method was employed. This involved heating the crystal to 700 K after deuteration and reacting the residual  $C_a$  with an  $O_2$  beam to produce CO. The area under the CO trace is directly proportional to the amount of unreacted carbon on the surface. The titration experiment was repeated on a  $CH_a$  adlayer that had not been deuterated. Both the CO profiles are shown in Fig. 13. More than 95% of the surface  $CH_a$  was removed by deuteration.

These results confirm the earlier conclusion<sup>10</sup> that  $CH_a$  is the stable species of methane dissociation at 370 K. First, the observed  $CHD_3$  and  $CD_4$  products are consistent with stepwise deuteration of  $CH_a$ . Second, the absence of gas phase  $C_2$  species and the virtually complete removal of the carbon-

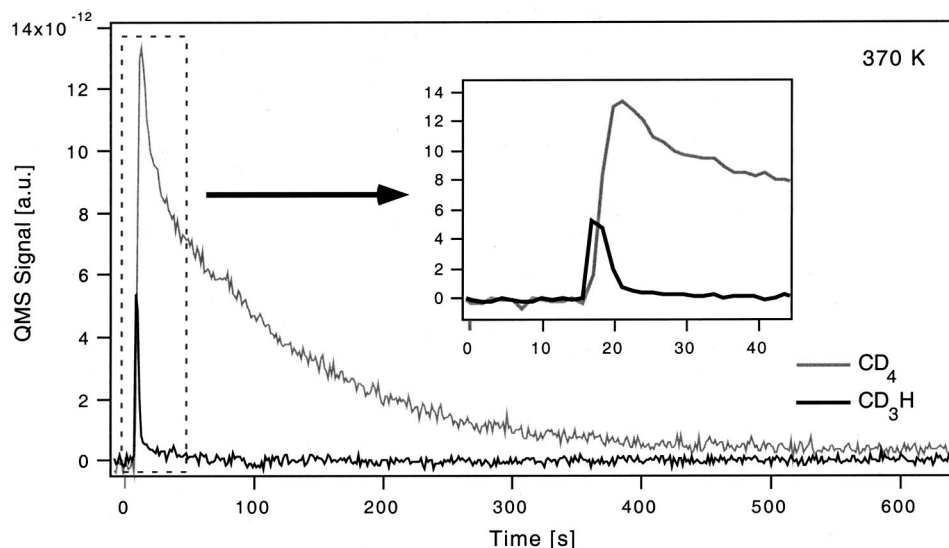


FIG. 12. Rehydrogenation of a  $0.12 \text{ ML } CH_a$  adlayer to produce  $CHD_3$  and  $CD_4$  using a  $D_2$  beam of  $1.2 \text{ ML s}^{-1}$  flux at a surface temperature of 370 K. The inset is the first 20 s of the reaction magnified.



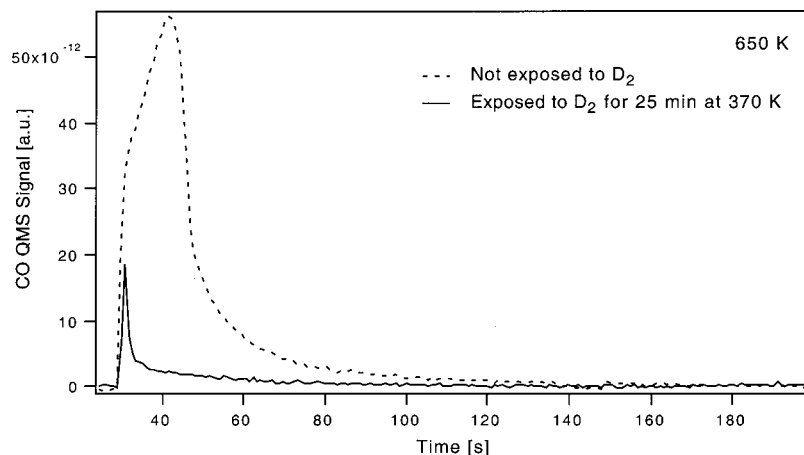


FIG. 13. Titration of  $C_a$  produced by  $CH_a$  dehydrogenation with an  $O_2$  molecular beam at a surface temperature of 700 K, with (solid line) and without (dashed line) performing the rehydrogenation experiment.

aceous adlayer by deuteration shows that  $C_2$  species are not present on the surface to a significant degree. If  $C_2$  species were present on the surface, deuteration should lead to  $CCD_{3a}$ . We conclude that the adlayer consists of at least 95%  $CH_a$ .

$CH_a$  dehydrogenates to produce  $C_a$  and gas phase  $H_2$  on heating to temperatures greater than 470 K.<sup>10</sup> It was found that carbon produced using this procedure could not be rehydrogenated under the conditions studied, namely  $D_2$  fluxes as high as  $1.2 \text{ ML s}^{-1}$  and surface temperature range 250–700 K. This is consistent with the work of Smirnov *et al.*<sup>27</sup> on Pt{111}. They found that atomic carbon produced using a carbon deposition source could be rehydrogenated above 240 K. However, if the surface was preannealed to 500 K, the  $C_a$  could no longer be rehydrogenated and was attributed to the formation of unreactive carbon in the form of graphite.

#### IV. MODELING THE EXCHANGE REACTION

##### A. The model

The reaction was modelled using the following elementary reaction steps:



where  $k_d$ ,  $k_1$ , and  $k_{-1}$  are the rate constants for  $H_2/D_2/HD$  desorption, the  $CH_a + D_a$  reaction and the  $CD_a + H_a$  reaction, respectively.  $F_{D_2}$ ,  $F_{H_2}$ , and  $s_0$  are the  $D_2$  flux,  $H_2$  flux and sticking probability. The first step is the reversible adsorption and dissociation of  $D_2$  (2). The next step is the reversible exchange via  $CHD_a$  (3). The exchanged  $H_a$  adatoms can either react with  $D_a$  atoms to produce HD (4) or another exchanged  $H_a$  to produce  $H_2$  (5). Since each HD or  $H_2$  molecule that is produced is pumped away the reaction (in

theory) can be driven to completion. (In practice, since background  $H_2$  is always present in the chamber, the  $CD_a + H_a$  exchange reaction always has a finite rate.)

Four coupled differential equations are used to describe the variation of adsorbate coverages:

$$\frac{d\theta_H}{dt} = -2k_d\theta_H^2 - k_d\theta_H\theta_D - k_{-1}\theta_{CD}\theta_H + k_1\theta_{CH}\theta_D + 2F_{H_2}s_0(1 - \kappa\theta_{CH})^2, \quad (6)$$

$$\frac{d\theta_D}{dt} = -2k_d\theta_D^2 - k_d\theta_H\theta_D + k_{-1}\theta_{CD}\theta_H - k_1\theta_{CH}\theta_D + 2F_{D_2}s_0(1 - \kappa\theta_{CH})^2, \quad (7)$$

$$\frac{d\theta_{CH}}{dt} = k_{-1}\theta_{CD}\theta_H - k_1\theta_{CH}\theta_D, \quad (8)$$

$$\frac{d\theta_{CD}}{dt} = -k_{-1}\theta_{CD}\theta_H + k_1\theta_{CH}\theta_D. \quad (9)$$

Here  $\theta_x$  is the coverage of species  $x$  relative to the saturation coverage of  $CH_a$  at 370 K and  $\kappa$  is a correction factor which takes into account that every  $CH_a$  fragment may block more than one  $H_2/D_2$  adsorption site. Weinberg and co-workers<sup>24</sup> found that on Pt{110}-(1×2) the desorption kinetics for  $H_2$ ,  $D_2$ , and HD are the same within experimental error and that  $H_2$  desorption was first order with an activation energy and pre-exponential factor which change with coverage. We found that for low  $H_2$  pre-coverages on a clean surface,  $H_2$

TABLE I. Parameters used in the model.

Reaction	Rate ( $s^{-1}$ )	$E_a$ ( $\text{kJ mol}^{-1}$ )	$\nu$ ( $\text{mol}^{-1} \text{ cm}^2 \text{ s}^{-1}$ )	Ref.
$D_2/H_2$ Flux	$F_{D_2/H_2}$	0.028 ( $\text{ML s}^{-1}$ )		Calculated
$D_2 \rightarrow 2D_a$	$s_0$	0.3		25
	$\kappa$	1		This work
$2H_a \rightarrow H_2$	$k_d$	65	$5.6 \times 10^{-4}$	24, 25
$2D_a \rightarrow H_2$	$k_d$	65	$5.6 \times 10^{-4}$	24, 25
$D_a + H_a \rightarrow H_2$	$k_d$	65	$5.6 \times 10^{-4}$	24, 25
$CH_a + D_a \rightarrow CD_a + H_a$	$k_1$	69.5	$5.6 \times 10^{-4}$	This work
$CD_a + H_a \rightarrow CH_a + D_a$	$k_{-1}$	73.2	$5.6 \times 10^{-4}$	This work

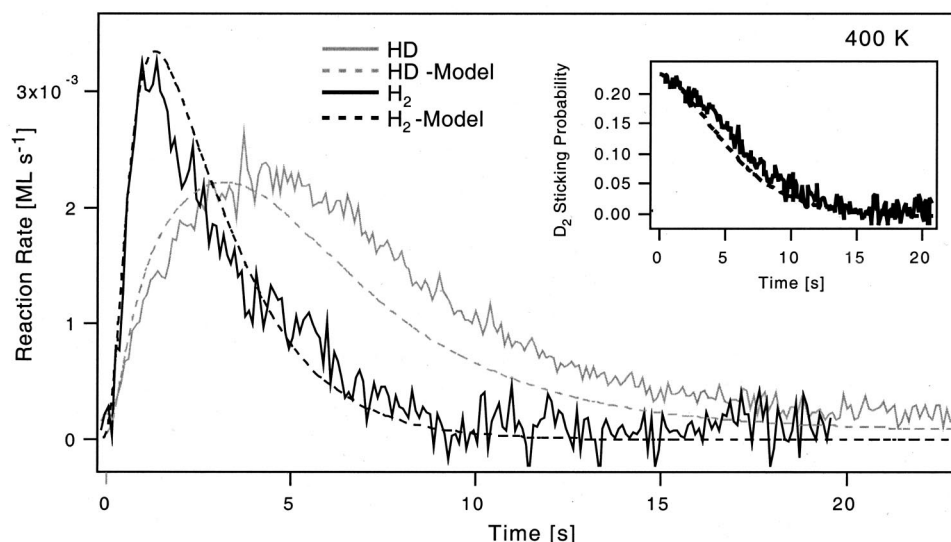


FIG. 14. Experimental (solid lines) and modeled (dashed lines) profiles of the H<sub>2</sub> and HD produced during the CH<sub>4</sub>+D<sub>2</sub> reaction, for a CH<sub>4</sub> precov-  
erage of 0.04 ML and D<sub>2</sub> flux of 0.028 ML s<sup>-1</sup>, at a surface temperature of 400 K. The inset shows the corresponding D<sub>2</sub> reactive sticking probability.

desorption is best described as a second order process with fixed kinetic parameters. Therefore, for simplicity in this model we describe the adsorption and desorption of H<sub>2</sub>, D<sub>2</sub>, and HD using second order Langmuirian behavior.

The above set of coupled differential equations cannot be solved explicitly and must be solved using numerical integration. The initial coverages and beam fluxes were determined experimentally. The parameters taken from the literature (where possible), are listed in Table I. The only unknowns were  $k_1$ ,  $k_{-1}$ , and  $\kappa$ . Reasonable guesses were made for these unknown parameters and the system of coupled differential equations was solved numerically, using Fortran routines (NAG library). This yielded time dependent coverages for all the surface species. These were inserted into the following set of equations which describe the time dependent D<sub>2</sub> sticking probability ( $s_{\text{D}_2}$ ), HD pressure ( $P_{\text{HD}}$ ) and H<sub>2</sub> pressure ( $P_{\text{H}_2}$ ):

$$s_{\text{D}_2} = s_0(1 - \kappa\theta_{\text{CH}})^2 - \frac{k_d\theta_{\text{D}_2}^2}{F_{\text{D}_2}}, \quad (10)$$

$$P_{\text{HD}} = k_d\theta_{\text{D}}\theta_{\text{H}}, \quad (11)$$

$$P_{\text{H}_2} = k_d\theta_{\text{H}}^2. \quad (12)$$

The resulting profiles were compared to the experimentally determined curves and the parameters  $k_1$ ,  $k_{-1}$ , and  $\kappa$  were varied until the best fit was obtained. In Fig. 14 the experimentally determined profiles and best fit theory profiles are shown for the exchange reaction at 400 K. The best fit parameters are included in Table I. The same procedure was applied to the reverse reaction, using the same parameters but different initial conditions (replacing the CH<sub>4</sub> adlayer with a CD<sub>4</sub> adlayer and the D<sub>2</sub> beam with a H<sub>2</sub> beam). The best fit is shown in Fig. 15. It is clear that there is a good quantitative fit for both directions using the same parameters.

We found that the model is insensitive to variations the absolute values of the rate constants to within  $\pm 50\%$ , but extremely sensitive to the ratio of the rate constants for the forward ( $k_1$ ) and reverse ( $k_{-1}$ ) reactions. The insensitivity of the model to surface temperature is reflected in the experimental behavior. For this reason we were unable to use an

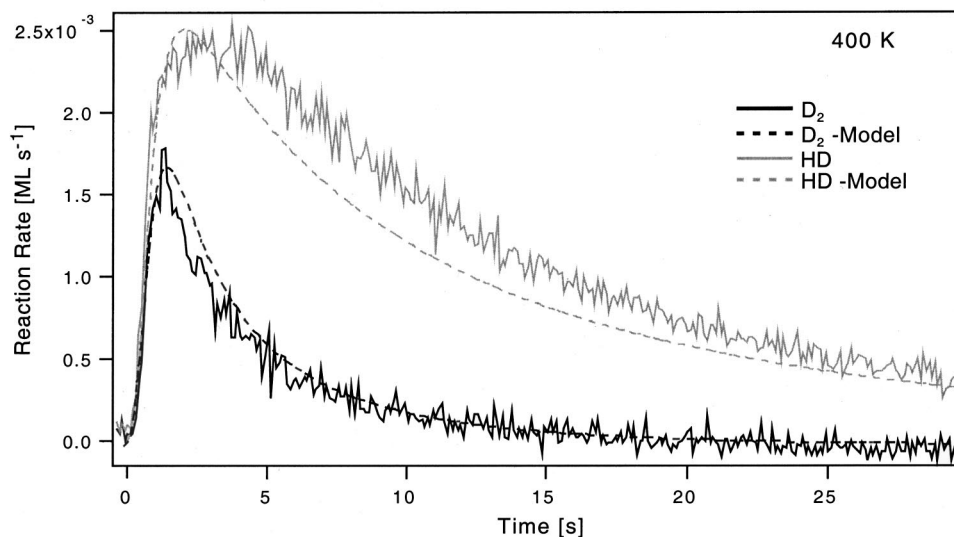


FIG. 15. Experimental (solid lines) and modeled (dashed lines) profiles of the D<sub>2</sub> and HD produced during the CD<sub>4</sub>+H<sub>2</sub> reaction at a surface temperature of 400 K.

TABLE II. The frequencies for the normal modes of vibration for CH<sub>a</sub>/CD<sub>a</sub> on different transition metal surfaces determined using HREELS.

Crystal	$\nu_1$ :C-H(C-D)	$\nu_2$ :M-CH(M-CD)	$\nu_{3,4}$ :C-H(C-D)
Ni{111} (Ref. 31)	2970(2220)	650(630)	1275(930)
Pd{100} (Ref. 34)	2940(2250)		925(715)
Rh{111} (Ref. 35)	2930(2220)		930
Pt{111} (Ref. 6)	2955		770
Pt{111} (Ref. 27)	2960(2220)		795(590)

Arrhenius analysis to determine the activation energy and pre-exponential factor for exchange. The best fit was obtained with  $k_1/k_{-1}=3.0$ . We obtain an estimate for the activation energies in each direction by assuming the same pre-exponential factor for H<sub>2</sub> and D<sub>2</sub> and for the forward and reverse surface reactions. This yields the activation energies for the CH<sub>a</sub>+D<sub>a</sub> reaction of 70 kJ mol<sup>-1</sup> and for the CD<sub>a</sub>+H<sub>a</sub> reaction of 73.2 kJ mol<sup>-1</sup>. These values compare favorably to the DFT slab calculations values derived by Michaelides and Hu on Pt{111}<sup>11</sup> and by Nørskov and co-workers on Ni{111}<sup>12</sup> of 94 kJ mol<sup>-1</sup> and 70 kJ mol<sup>-1</sup>, respectively. A higher pre-exponential factor would give an activation energy closer to that calculated by Michaelides and Hu.

## B. Theoretical estimation of the kinetic isotope effect

We have shown that the exchange process is described by the following equilibrium:



We will assume that exchange occurs in both directions via a CHD<sub>a</sub> transition state. We can therefore use transition state theory to determine the rate constant, in either direction, from the properties of the reactants and the transition state.<sup>28-30</sup> The KIE which is the ratio of the rate constants is given by the following expression:

$$\frac{k_1}{k_{-1}} = \frac{Q_{\text{CD}}Q_{\text{H}}}{Q_{\text{CH}}Q_{\text{D}}} e^{\Delta E/k_B T}, \quad (14)$$

where

$$\Delta E = + \sum_i \frac{1}{2} \frac{h\nu_{i(\text{CH})}}{k_B T} + \sum_i \frac{1}{2} \frac{h\nu_{i(\text{D})}}{k_B T} - \sum_i \frac{1}{2} \frac{h\nu_{i(\text{CD})}}{k_B T} - \sum_i \frac{1}{2} \frac{h\nu_{i(\text{H})}}{k_B T} \quad (15)$$

is the difference in zero point energy between the reactants and the products, summing over all the vibrational modes, and Q<sub>X</sub> is the total partition function of species X.

In our present analysis a rigid solid surface is assumed: the surface partition functions are unity. We also assume that the reactants and transition states are localized on the surface. The total partition function is equated to the total vibrational partition function, Q<sub>vib</sub>. To evaluate Q<sub>vib</sub> it was assumed that both the frustrated rotational and vibrational bending modes are doubly degenerate and have the same frequency as on the {111} surface, as shown in Table II. A

TABLE III. Partition functions for the individual vibrational modes, total partition functions, and total zero point energies for the exchange reaction at a surface temperature of 400 K.

Species	$q_1$	$q_2$	$q_3$	$q_4$	$q_{5,6}$	$Q_X$	$\sum_i \frac{1}{2} \frac{h\nu_i}{k_B T}$
CH <sub>a</sub>	1	1.106	1.061	1.061	1.947	4.72	10.089
CD <sub>a</sub>	1	1.115	1.135	1.135	1.995	5.72	7.956
H <sub>a</sub>	1.013	1.198	1.198			1.45	3.964
D <sub>a</sub>	1.041	1.310	1.310			1.79	3.062

value for the metal-carbon stretch was taken from Ni{111} data;<sup>31</sup> HREELS studies on other isotopically substituted hydrocarbon fragments show that the metal-carbon stretching frequency is not changed significantly by isotopic substitution of H in CH<sub>x</sub>, where  $x=0-3$ . A reduction in frequency of about 20 cm<sup>-1</sup> when H is replaced by D is typical. Frequencies for the frustrated translations  $\nu_5$  and  $\nu_6$  have not been experimentally determined for CH<sub>a</sub>. A frequency of 200 cm<sup>-1</sup> was chosen for the two frustrated translation modes  $\nu_5$  and  $\nu_6$ . Since the change in frequency which occurs after isotopic substitution is the frequency ratio<sup>32</sup>

$$\frac{\nu_{5,6(\text{CH})}}{\nu_{5,6(\text{CD})}} = \left( \frac{M_{(\text{CD})}}{M_{(\text{CH})}} \right)^{1/2}, \quad (16)$$

where  $M_{(\text{CH})}$  and  $M_{(\text{CD})}$  are the masses of CH and CD, respectively, the contribution to the calculated KIE is insensitive to the absolute choice of frequency.

Since Pt-H stretching frequencies for adsorbed H<sub>a</sub> on Pt{110} are not available, frequencies were obtained from data for the Pt{111} surface: Bruchmann and co-workers<sup>33</sup> found  $\nu_1(\text{Pt-H})$  and  $(\text{Pt-D})$  to be at 1200 and 900 cm<sup>-1</sup>, respectively, and the  $\nu_{2,3}$  and  $(\text{Pt-H})$  and  $(\text{Pt-D})$  to be 500 and 400 cm<sup>-1</sup>, respectively. These frequencies were used to calculate the total partition functions, shown in Table III. The total zero point energy for each species is also included.

We estimate the kinetic isotope effect using Eq. (14) to be 3.36, which agrees very well with the value of 3.0 obtained by fitting the model to the experimental data. Therefore we conclude that QM tunneling is not significant for the exchange reaction at 400 K.

## V. SUMMARY AND CONCLUSION

The D<sub>2</sub> exchange of H in CH<sub>a</sub> was found to be extremely facile at a surface temperature of 350 K. The exchange occurs via a Langmuir-Hinshelwood reaction between a D<sub>a</sub> atom and a CH<sub>a</sub> fragment, to produce HD and H<sub>2</sub>. The reaction rate is quite insensitive to the reaction temperature over the surface temperature range studied (370–420 K), which suggests a low activation energy.

Surface CH<sub>a</sub> is completely deuterated to CHD<sub>3</sub> and CD<sub>4</sub> at a high D<sub>2</sub> flux of 1.2 ML s<sup>-1</sup>, and the process can be ascribed to a stepwise deuteration mechanism.

The reverse exchange reaction, CD<sub>a</sub>+H<sub>a</sub>, was found to occur at about half the rate. The exchange process is successfully modeled using a system of four coupled differential equations, which describe the rate of change of the adsorbate coverages. Finally, the difference in rate between the forward

and reverse reactions is readily attributed to zero point energy differences; quantum mechanical tunneling of H/D need not be invoked.

## ACKNOWLEDGMENTS

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